

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Patent Application of:

**Hacene Lahreche, et al.**

Serial No. 10/516,358

Filed: November 24, 2004

For: METHOD FOR EPITAXIAL GROWTH  
OF A GALLIUM NITRIDE FILM  
SEPARATED FROM ITS SUBSTRATE

Examiner: Matthew J. Song

Art Unit: 1722

**SUBMISSION PURSUANT TO 37 C.F.R. §114(c)**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated July 10, 2007, Applicants submit the following submission including amendments and remarks in connection with a Request for Continued Examination pursuant to 37 C.F.R. §114 filed concurrently herewith: